

TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT**(Under 37 CFR 1.97(b) or 1.97(c))**

Docket No.

17289

In Re Application Of: Moon-Hee Hong, et al.

Application No.

10/724,381

Filing Date

November 28, 2003

Examiner

Daniel J. Jenkins

Customer No.

23389

Group Art Unit

1742

Confirmation No.

9654

Title: **W-Cu ALLOY WITH HOMOGENOUS MICRO-STRUCTURE AND THE MANUFACTURING METHOD THEREOF**

Address to:

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

37 CFR 1.97(b)

1. ☐ The Information Disclosure Statement submitted herewith is being filed within three months of the filing of a national application other than a continued prosecution application under 37 CFR 1.53(d); within three months of the date of entry of the national stage as set forth in 37 CFR 1.491 in an international application; before the mailing of a first Office Action on the merits, or before the mailing of a first Office Action after the filing of a request for continued examination under 37 CFR 1.114.

37 CFR 1.97(c)

2. ☒ The Information Disclosure Statement submitted herewith is being filed after the period specified in 37 CFR 1.97(b), provided that the Information Disclosure Statement is filed before the mailing date of a Final Action under 37 CFR 1.113, a Notice of Allowance under 37 CFR 1.311, or an Action that otherwise closes prosecution in the application, and is accompanied by one of:

☐ the statement specified in 37 CFR 1.97(e);

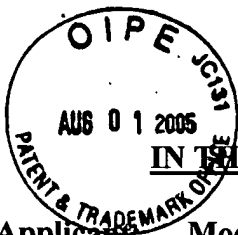
OR

☒ the fee set forth in 37 CFR 1.17(p).

Docket No.
17289

Application No.	Filing Date	Examiner	Customer No.	Group Art Unit	Confirmation No.
10/724,381	November 28, 2003	Daniel J. Jenkins	23389	1742	9654

P10A/REV05



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Moon-Hee Hong, et al.

Examiner: Daniel J. Jenkins

Serial No.: 10/724,381

Group Art Unit: 1742

Filed: November 28, 2003

Docket: 17289

For: W-Cu ALLOY WITH
HOMOGENOUS MICRO-
STRUCTURE AND THE
MANUFACTURING METHOD THEREOF

Dated: July 28, 2005

Confirmation No. 9654

Mailstop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Sir:

In accordance with 37 C.F.R. §§1.97 and 1.98, it is requested that the following references, which are also listed on the attached Form PTO-1449, be made of record in the above-identified case.

1. Japanese Laid-Open Patent Publication No. 04-049642, dated February 19, 1992;
2. Japanese Laid-Open Patent Publication No. 03-120324, dated May 22, 1991; and

CERTIFICATE OF MAILING UNDER 37 C.F.R. § 1.8(a)

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P. O. Box 1450, Alexandria, VA 22313-1450 on July 27, 2005.

Dated: July 28, 2005


Mark J. Cohen

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3. Japanese Patent No. 44-19016, issued August 18, 1969.

The references were cited in an Office Action dated April 19, 2005 received from the Japanese Patent Office. Applicants are submitting copies of the above-cited references, with an abstract in the English language of the references that were cited in the corresponding Japanese application.

Inasmuch as this Information Disclosure Statement is being submitted in accordance with the schedule set out in 37 C.F.R. § 1.97(c), a check in the amount of \$180.00 is enclosed.

Respectfully submitted,



Mark J. Cohen
Reg.No.: 32,211

Scully, Scott, Murphy & Presser
400 Garden City Plaza, Suite 300
Garden City, New York 11530
(516) 742-4343

MJC:kd

